

## Verfahren zur Herstellung hochreiner Lösungen unter Verwendung von gasförmigem Fluorwasserstoff

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### Abstract of **DE19914243**

The invention relates to a method for producing a high-purity solution that contains hydrogen fluoride or a salt thereof or a mixture of two or more thereof. The inventive method comprises the following step (i): hydrogen fluoride is passed into at least one anhydrous solvent. The method is characterised in that hydrogen fluoride is passed into the at least one anhydrous solvent as a gas or liquid gas or as a mixture of gas and liquid gas.

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